



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
 www.uspto.gov

BIB DATA SHEET

CONFIRMATION NO. 7187

SERIAL NUMBER 10/574,281	FILING or 371(c) DATE 03/31/2006 RULE	CLASS 250	GROUP ART UNIT 2881	ATTORNEY DOCKET NO. 033272343	
APPLICANTS Sei Umisedo, Kyoto, JAPAN; Nariaki Hamamoto, Kyoto, JAPAN; ** CONTINUING DATA ***** This application is a 371 of PCT/JP04/19833 12/28/2004 ** FOREIGN APPLICATIONS ***** JAPAN 2004-001006 01/06/2004 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 10/03/2006					
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and /MICHAEL P MASKELL/ Acknowledged Examiner's Signature	<input type="checkbox"/> Met after Allowance Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 07	TOTAL CLAIMS 10	INDEPENDENT CLAIMS 6
ADDRESS FINNEGAN, HENDERSON, FARABOW, GARRETT & DUNNER LLP 901 NEW YORK AVENUE, NW WASHINGTON, DC 20001-4413 UNITED STATES					
TITLE Ion beam measuring method and ion implanting apparatus					
FILING FEE RECEIVED 1500	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		